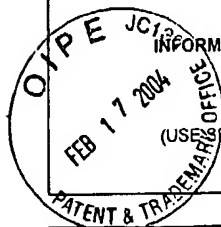


FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
MICRON.098CDV1APPLICATION NO.
10/614,489INFORMATION DISCLOSURE STATEMENT
BY APPLICANT

(USE SEVERAL SHEETS IF NECESSARY)

APPLICANT
Basceri et al.FILING DATE
July 3, 2003GROUP
2812

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
DV	1	6,339,527	01/2002	Farooq et al.			
	2	6,277,436	08/2001	Stauf et al.			
	3	5,822,175	10/1998	Azuma, Masamichi			
	4	5,581,436	12/1996	Summerfelt et al.			
	5	5,185,689	02/1993	Maniar, Papu D.			
DV	6	6,660,535	12/2003	Basceri et al.			

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

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EXAMINER <i>Andard</i>	DATE CONSIDERED <i>04/02/04</i>
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	


FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (USE SEVERAL SHEETS IF NECESSARY)	ATTY. DOCKET NO. MICRON.098CDV1	APPLICATION NO. Unknown
	APPLICANT Basceri et al.	
	FILING DATE Herewith	GROUP Unknown

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
DV	1	5,335,138	08/02/94	Sandhu et al.			
	2	5,406,445	04/11/95	Fujii et al.			
	3	5,506,166	04/09/96	Sandhu et al.			
	4	5,717,234	02/10/98	Si et al.			
	5	5,781,404	07/14/98	Summerfelt et al.			
	6	5,783,253	07/21/98	Roh			
	7	5,889,299	03/30/99	Abe et al.			
	8	5,973,911	10/26/99	Nishioka			
	9	6,010,931	01/04/00	Sun et al.			
	10	6,117,482	09/12/00	Kawahara et al.			
	11	6,136,639	10/24/00	Seon			
DV	12	6,319,764 B1	11/20/01	Basceri et al.			

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)	
DV	13	Hiromi Itoh et al., "Integration of BST Thin Film for Dram Fabrication", Integrated Ferroelectrics, 1995 Vol. 11, pp 101-109
DV	14	C. Basceri, "An Important Failure Mechanism in MOCVD (Ba,Sr)TiO ₃ Thin Films: Resistance Degradation", Ferroelectric Thin Films IV, Materials Research Society, Symposium Proceedings Volume 493, 1998, pp. 9-14
DV	15	Chung Ming Chu and Pang Lin, "Electric Properties and Crystal Structure of a (Ba,Sr)TiO ₃ Films Prepared at Low Temperatures on a LaNiO ₃ Electrode by Radio-Frequency Magnetron Sputtering", Appl. Phys. Lett., Vol. 70 (2), 13 January 1997, pp.249-51.

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EXAMINER <i>Philand</i>	DATE CONSIDERED <i>04/02/04</i>
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 FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (USE SEVERAL SHEETS IF NECESSARY)	ATTY. DOCKET NO. MICRON.098CDV1		APPLICATION NO. Unknown	
	APPLICANT Basceri et al.			
	FILING DATE July 3, 2003		GROUP Unknown	

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
DV	1.	6,238,966	05/29/01	Ueda et al.			

FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
DV	2.	0 617 439 A2	3/24/94	EPO			
DV	3.	JP 406333772A	12/2/94	Japan			

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EXAMINER <i>Richard</i>	DATE CONSIDERED <i>04/02/04</i>
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